IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yuan-Sheng Huang

Application No.: 10/00/4,614 (CONF 8180)

Group Art Unit:

Filed: 11/1/2001

1763

Examiner:

Title: Chamber-reversed dry etching

Luz L. Alcjandro Mulero

Attorney Docket No.: 67,200-565

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Commissioner for Patents Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Patent Office via facsimile no. (703) 872-9311 on thec

RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

in response to the Final Office Action of April 14, 2004, please amend this application as follows:

ENDROCE 1/16/64

XRD 1/24/04

PACE 2/11 * RCVD AT 6/9/2004 2:05:40 PM [Eastern Daylogh Time] * SVR-USPTO-EFXRF-111 * DNIS:3/72011 * CSID:1218/6404035 * DARATION (min-es):00-32